
Coherent Light Source R&D at MIT

W.S. Graves, F.X. Kärtner, D.E. Moncton (MIT)

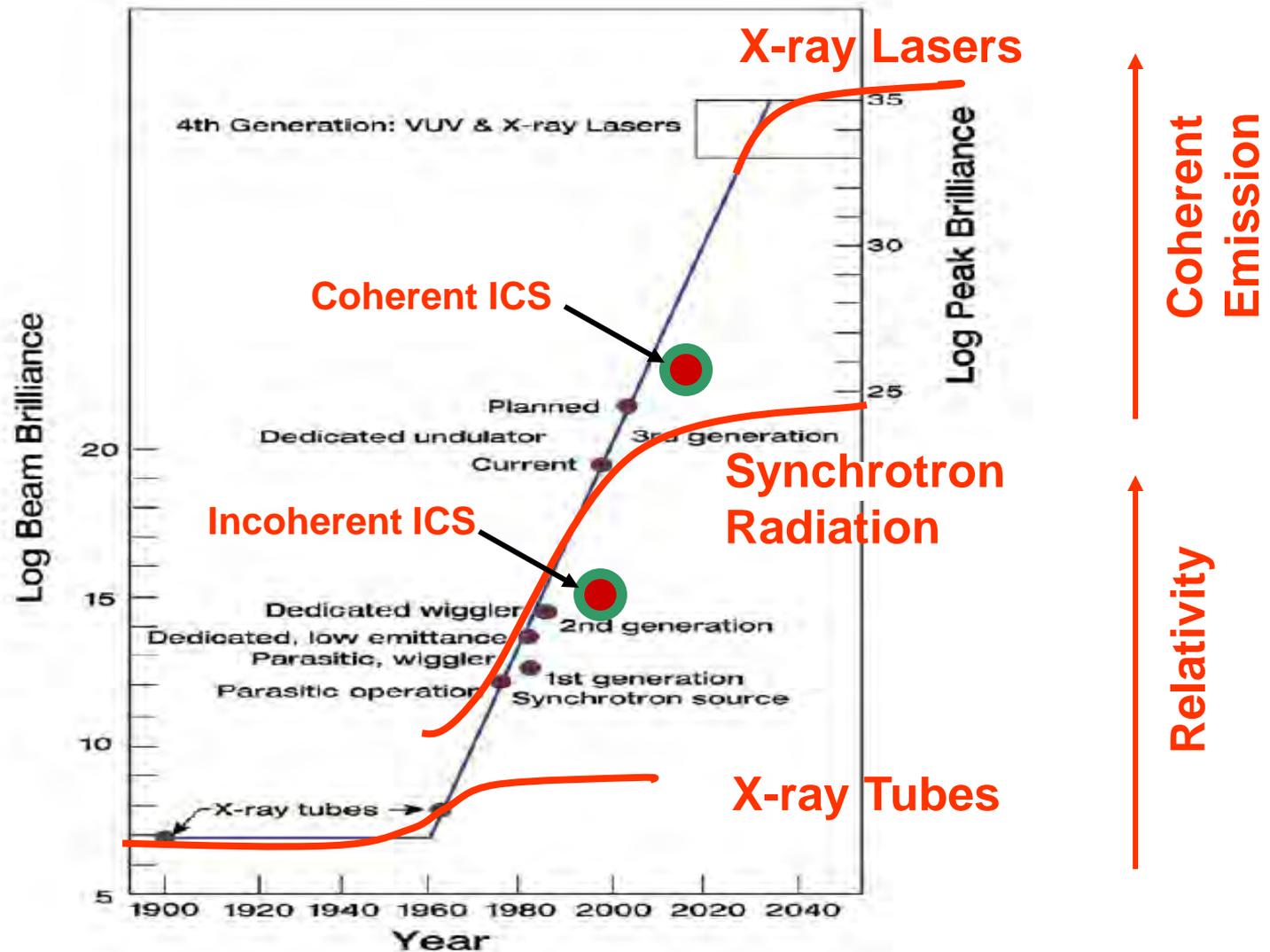
Ph. Piot (NIU)

August, 2011

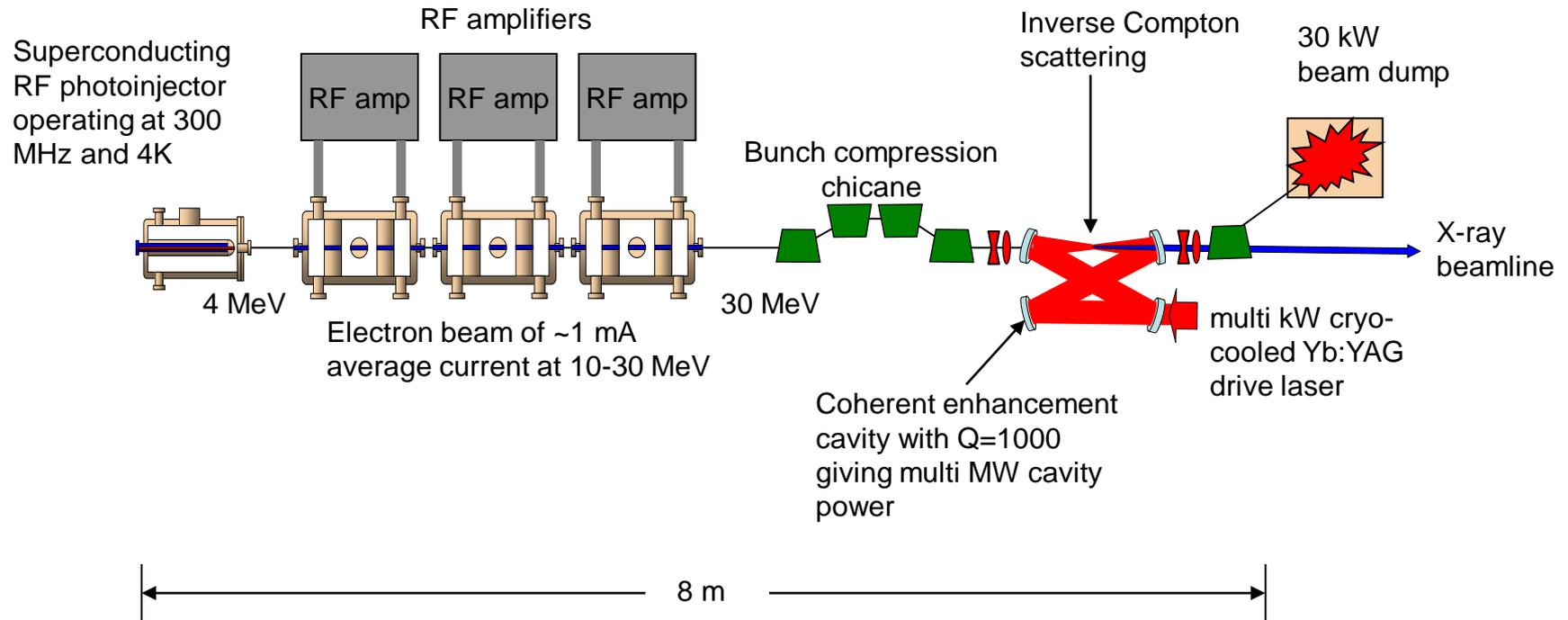
Annapolis, MD



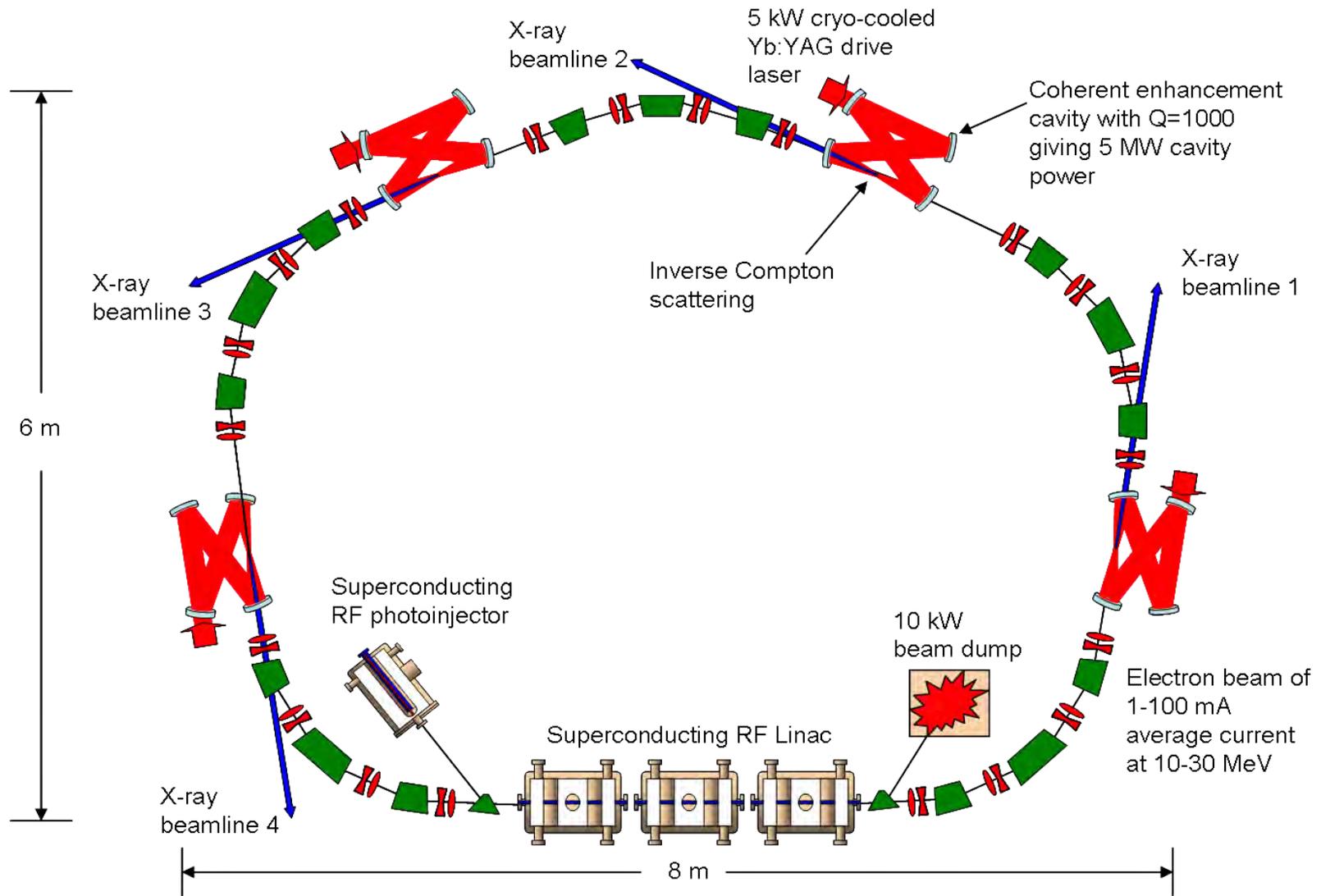
Light Source Performance



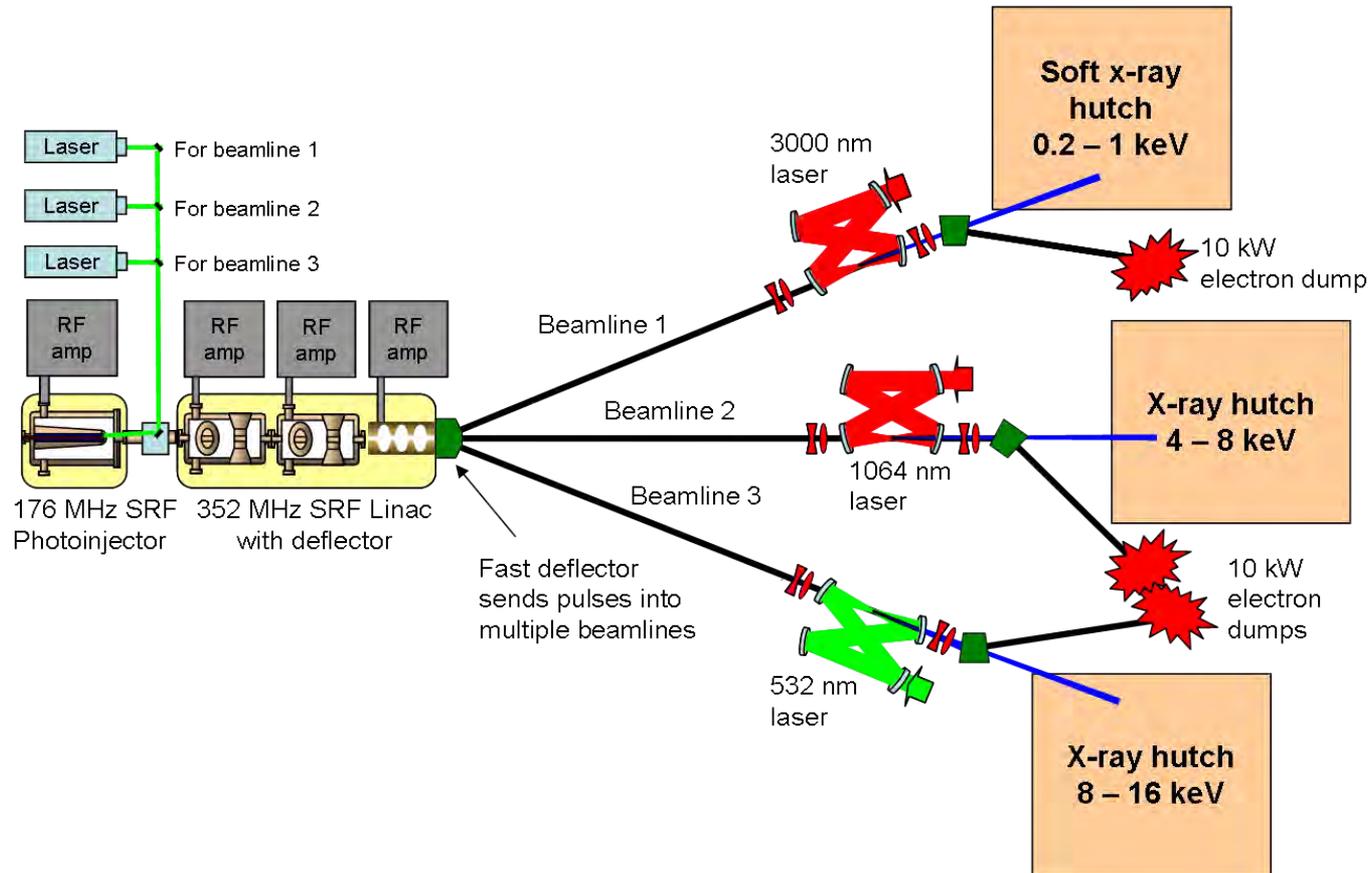
High Repetition Rate ICS with SRF Linac



ERL driving 4 X-ray Beamlines



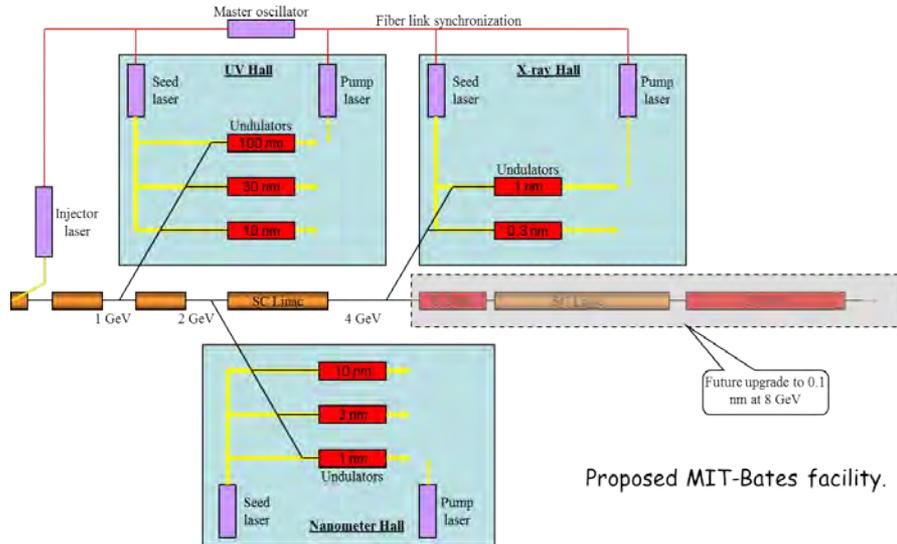
Concept for Multi Beamlines, Multi Independent Energies



Use 3 photocathode drive lasers with different arrival times to generate pulses into multiple beamlines each with independently tunable energy.

FEL Facility Design

2004 MIT-Bates FEL Proposal

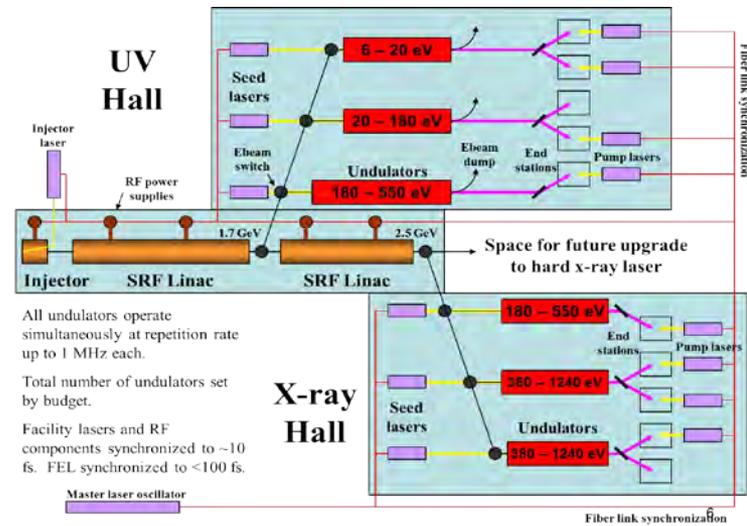


Proposed MIT-Bates facility.

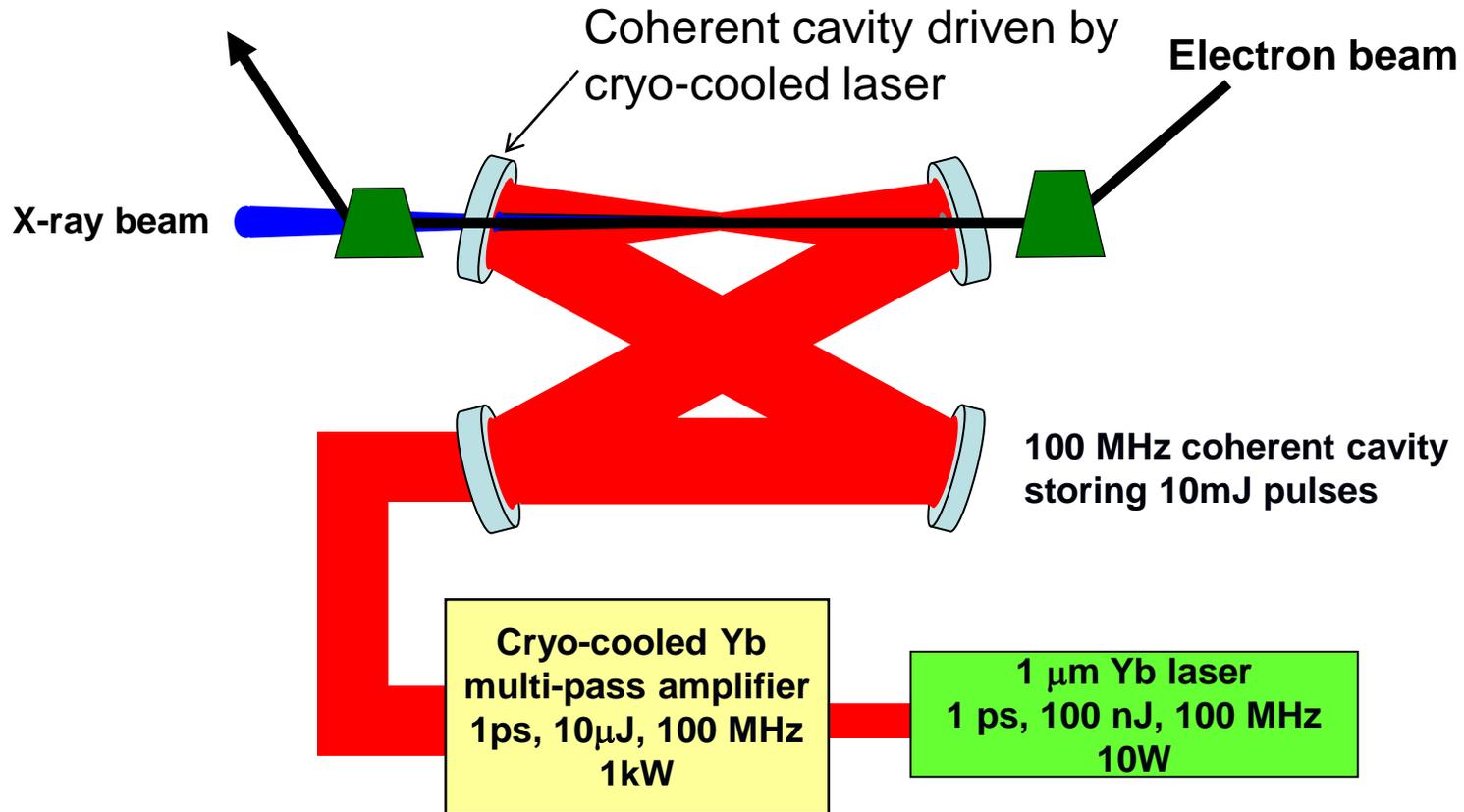
- Many tunable beamlines
- Fully coherent seeded operation
- CW Superconducting RF
- High rep rate
- Lasers tightly integrated

A next generation light source will adopt many of the concepts pioneered in these designs

2007 WiFEL Proposal



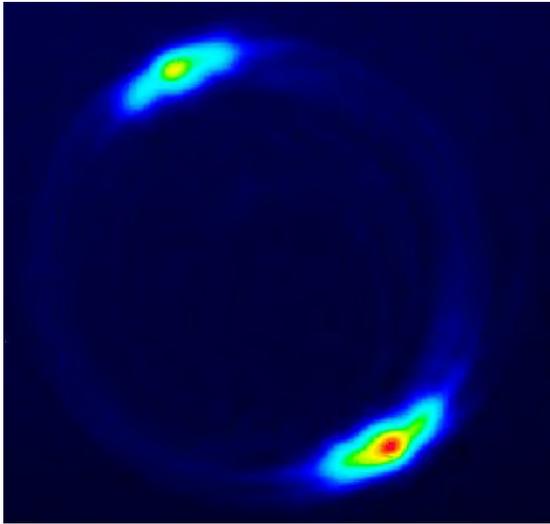
High Power Laser Technology



Coherent cavity stores $\sim 1000X$ laser amplifier power. Uses Bessel-Gauss ring-shaped modes to avoid mirror damage and oscillator instability.

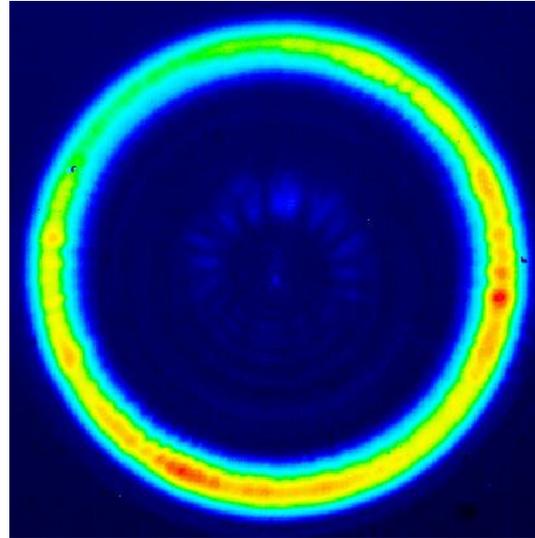
Cavity Results With Two Patterned Mirrors

Misaligned Cavity (sweep)



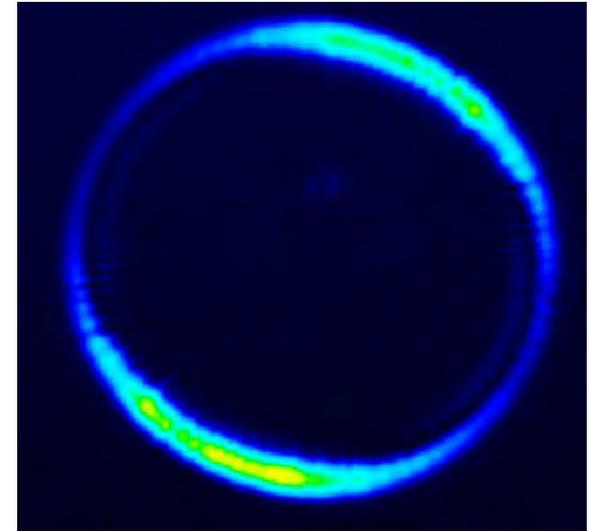
Finesse ~300

Aligned Cavity (sweep)



Finesse ~ 60

Aligned Cavity (locked)



Dramatic finesse drop on alignment (expected finesse ~300)

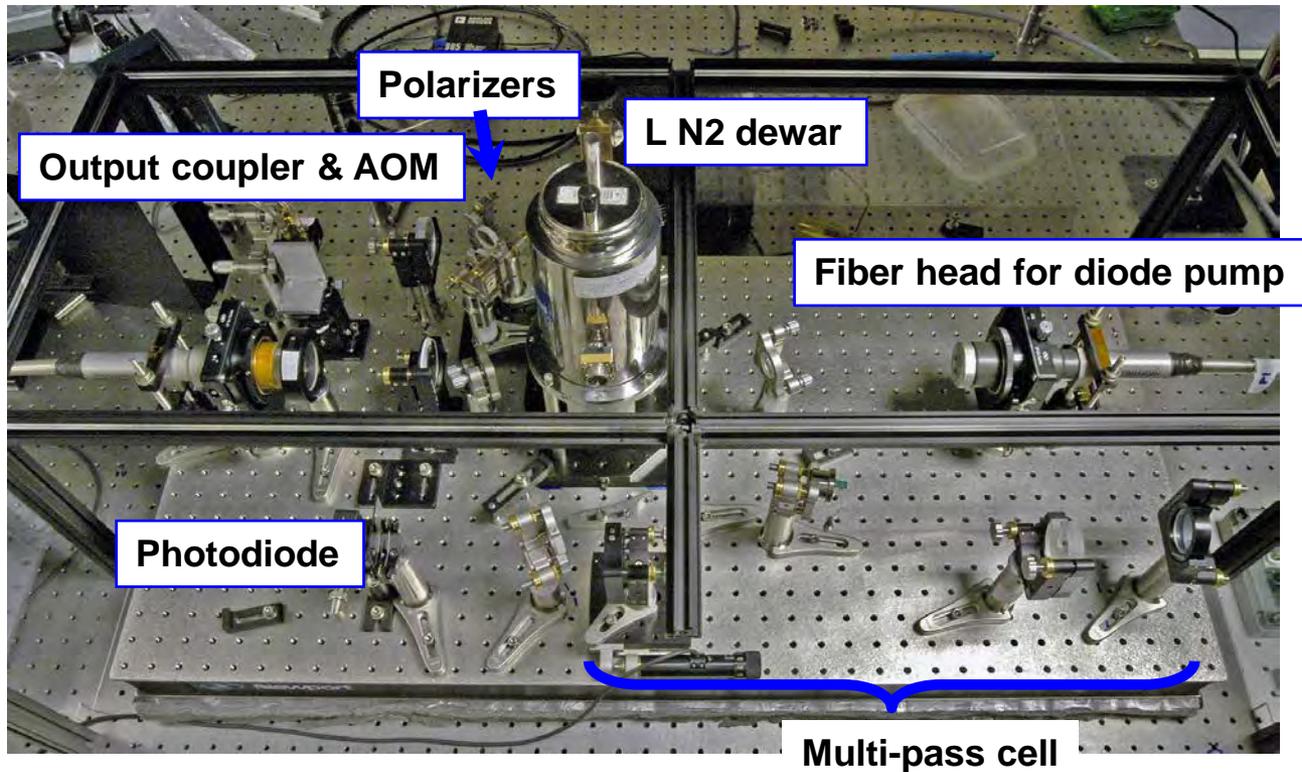
Transverse profile also changes from sweep to lock—Implication: sweep sums multiple transverse shapes.

Analog to Microwave Cavity

Cryo-cooled Laser Amplifier

200 W cryo-cooled Yb:YAG

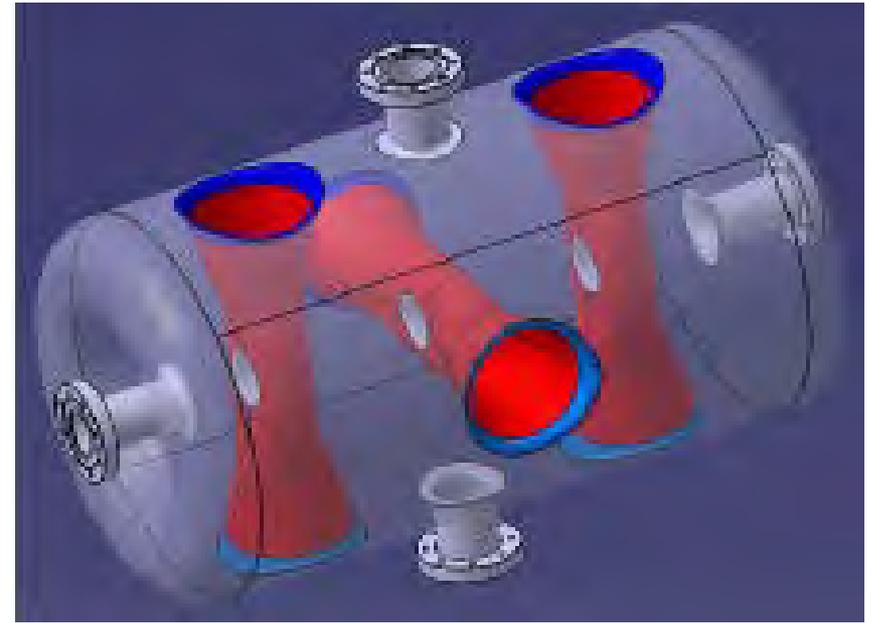
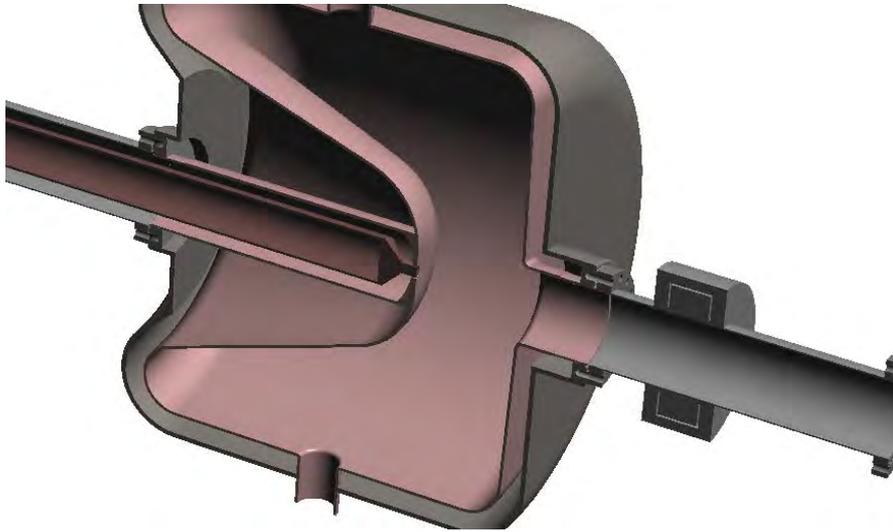
developed at MIT-Lincoln Lab by T.Y. Fan group



Pursuing R&D on mode-locking and Yb:YLF for sub-ps pulses

Next Generation SRF Cavities at 4K

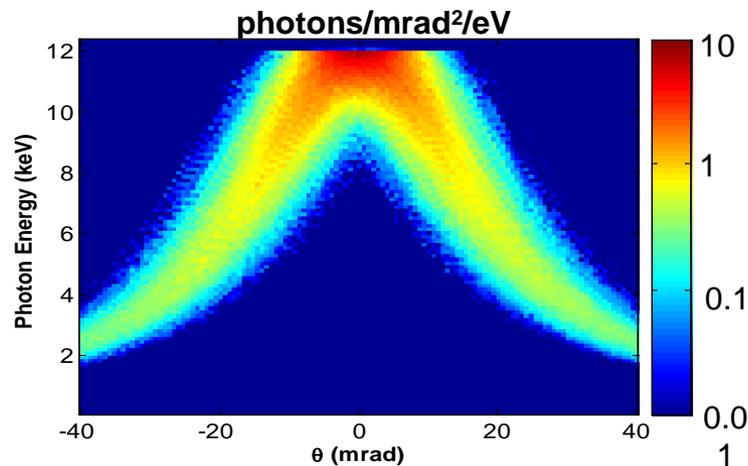
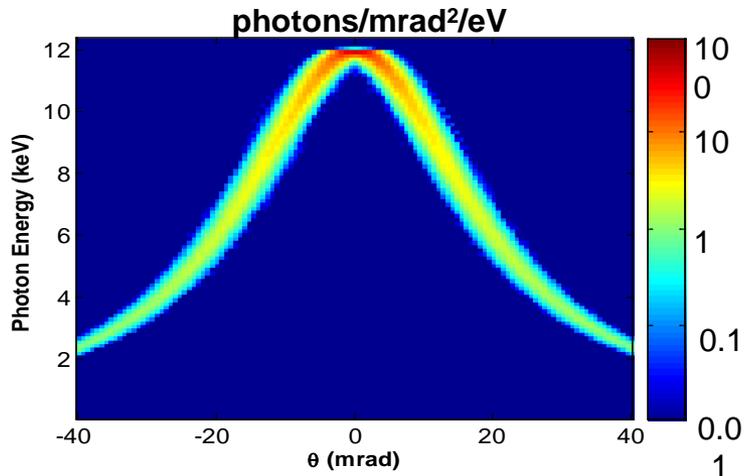
**1/4-wave resonator gun with
UW, Naval Postgraduate
School, Niowave Inc, Jlab**



Spoke cavity development with Jlab

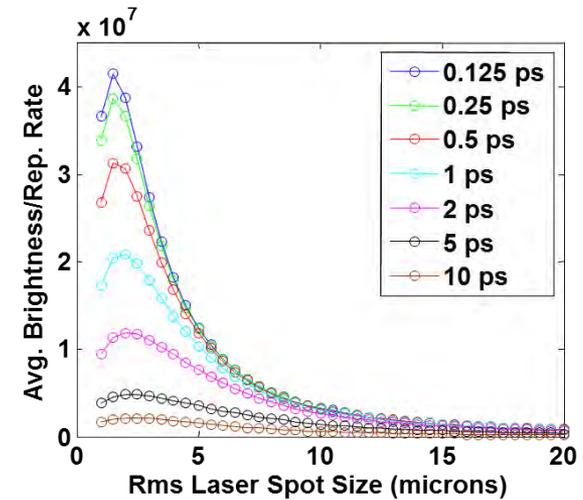
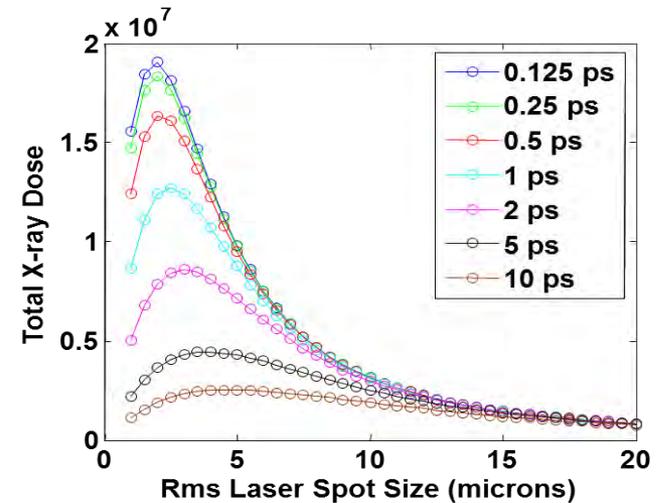
ICS Performance Optimization

Normalized emittance = $0.3 \mu\text{m}$



Normalized emittance = $1.0 \mu\text{m}$

Winthrop Brown (MIT Lincoln Lab)



Coherent X-rays via ICS

New Idea to produce coherent x-rays. No FEL required.

Arrange electrons to have periodic modulation, as if they had been bunched by FEL interaction.

Combine two key technologies: nanocathode array and emittance exchange

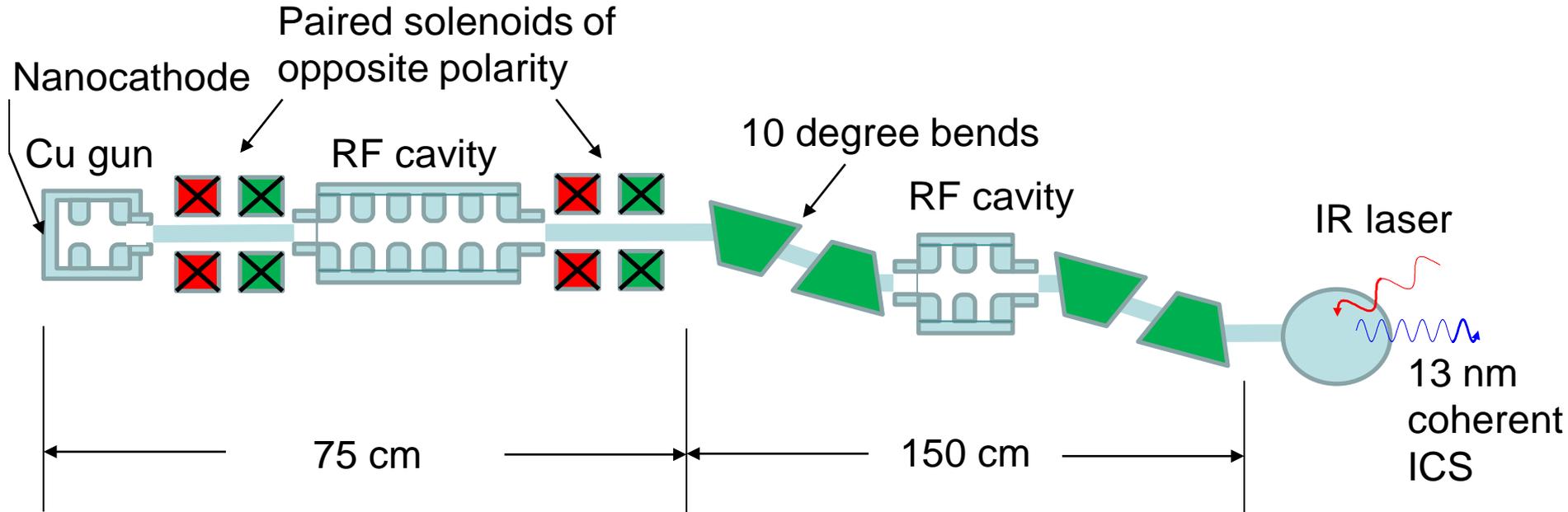
Steps

1. Emit array of beamlets from Field Emission Array nanocathode.
2. Accelerate and focus beamlet array.
3. Perform emittance exchange (EEX) to swap beamlet spacing into longitudinal dimension. Arrange dynamics to give desired period.
4. Coherently bunched beam emits ICS x-rays in phase.

Coherent ICS Example at 13 nm

FEA → gun → focus → emittance-exchange → coherent ICS

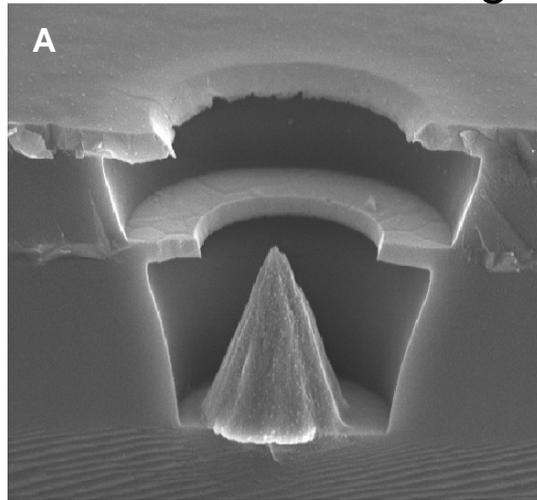
Electron energy ~2 MeV



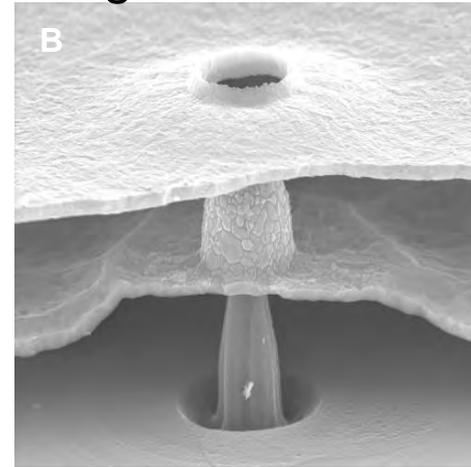
Double Gated Field Emitter Array

for collimating / focusing e-beam

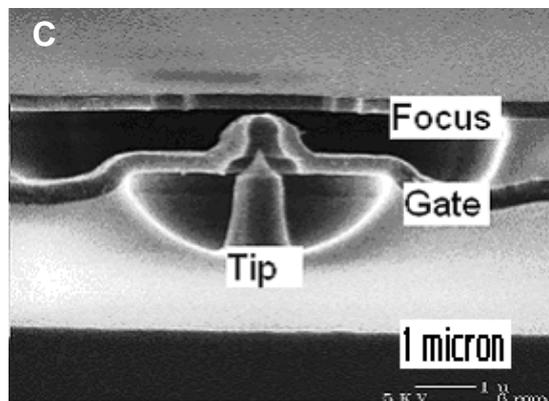
Mo Tip



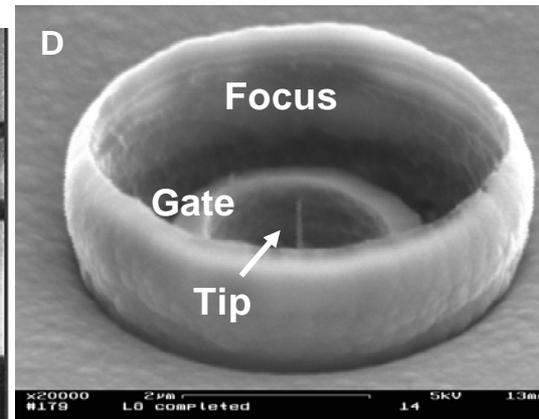
Si Tip



Si Tip



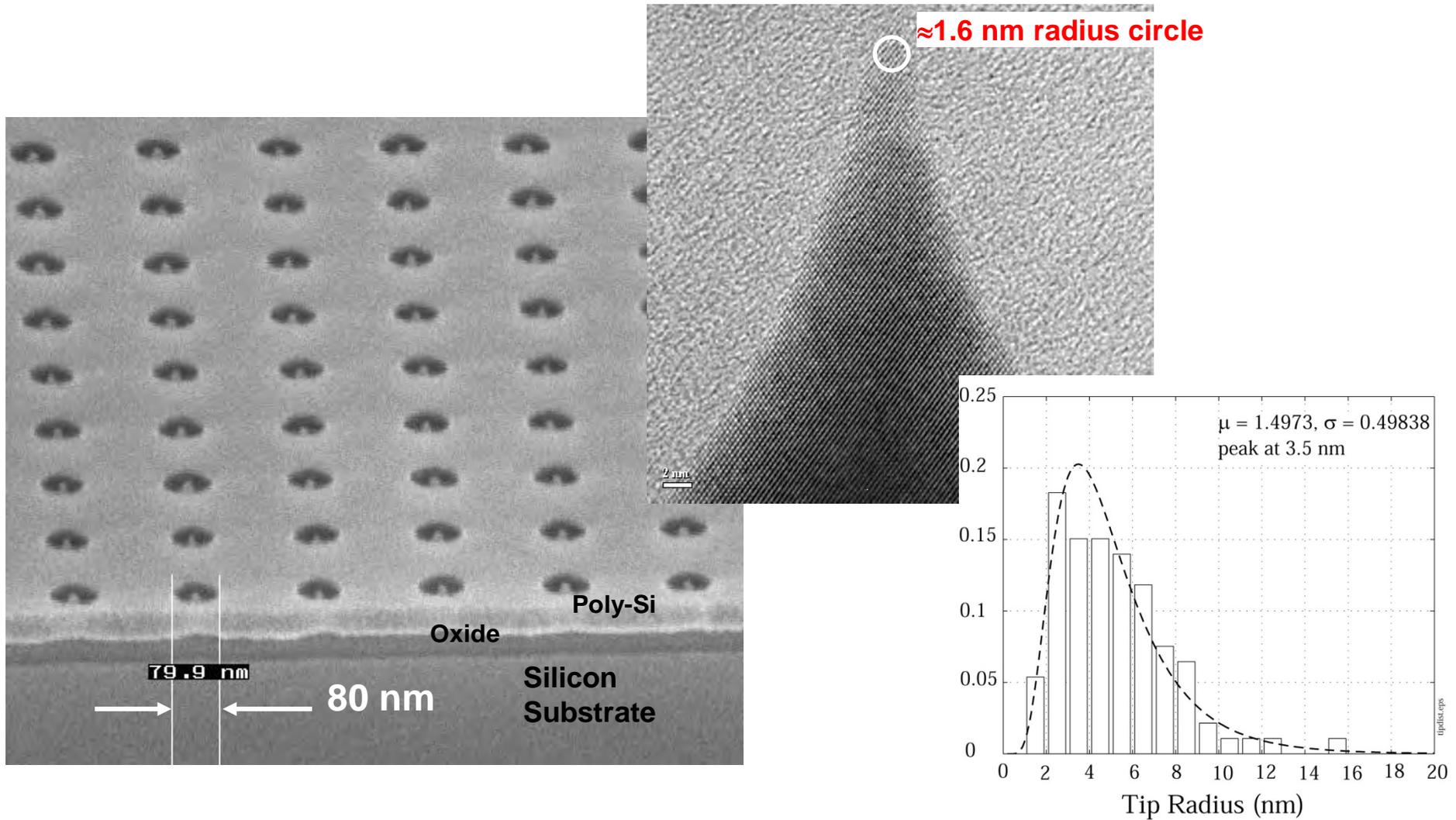
CNT Tip



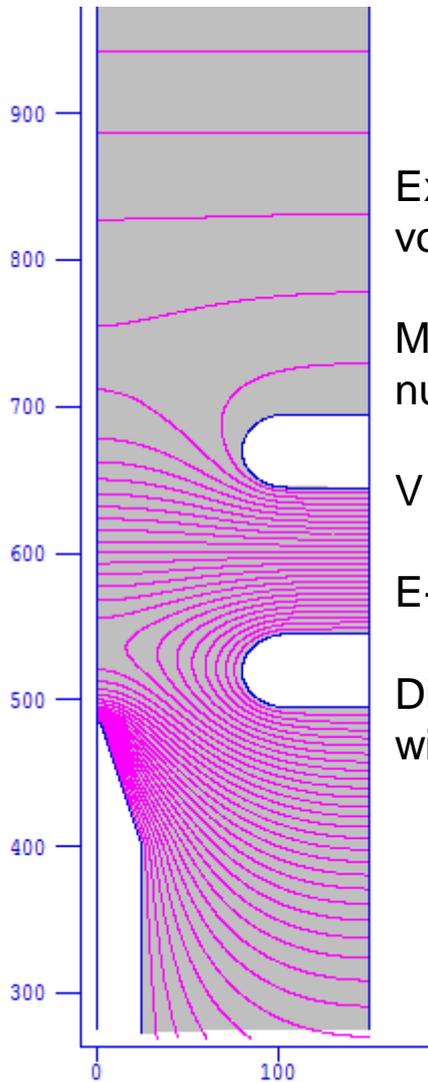
T. Akinwande & L. Velasquez-Garcia, MIT Microsystems Technology Lab

K. Berggren, MIT Nanostructures Lab

Field Emitter Array with 200 nm Pitch



Poisson Model of Tip Electric Field



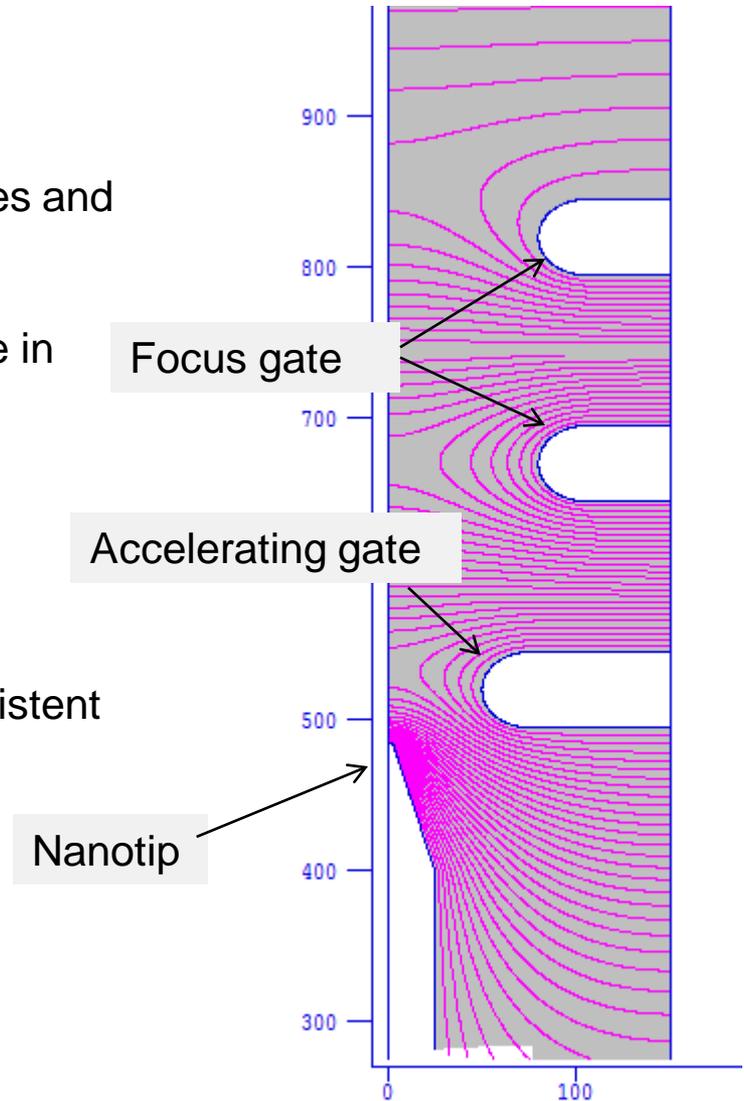
Exploring wide variety of geometries and voltages.

Modeling at nm scale requires care in numerical set up.

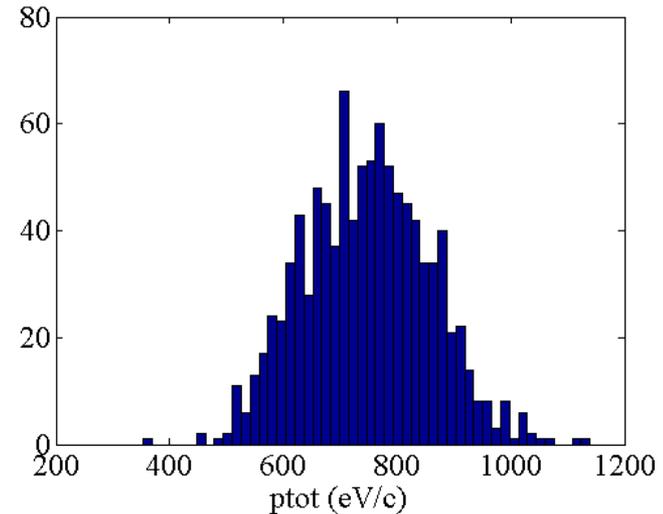
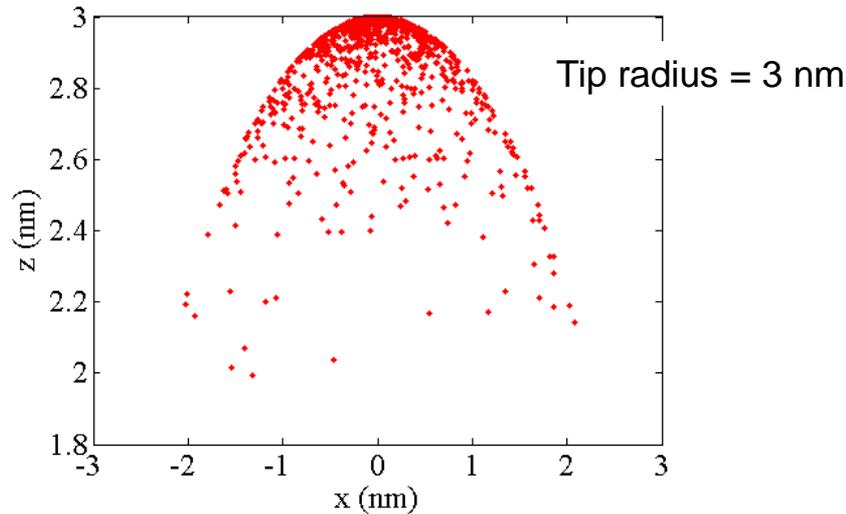
$V \sim 10\text{-}50$ V on gates

E-field at tip $\sim 10^{10}$ V/m

Dimensions and voltages are consistent with FEAs produced in the lab



Initial Electron Distribution on Nanotip

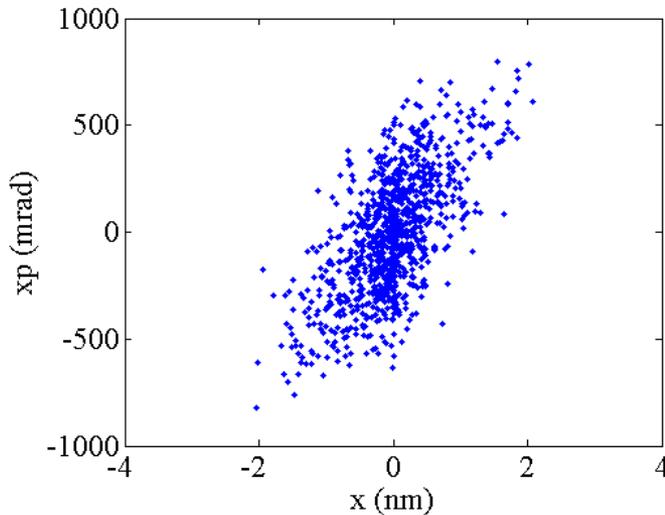


Initial K.E. ~ 0.5 eV

$\text{sig}_x = 0.60$ nm from F.-N. and surface field
 $\text{sig}_{px} = 163.17$ eV/c

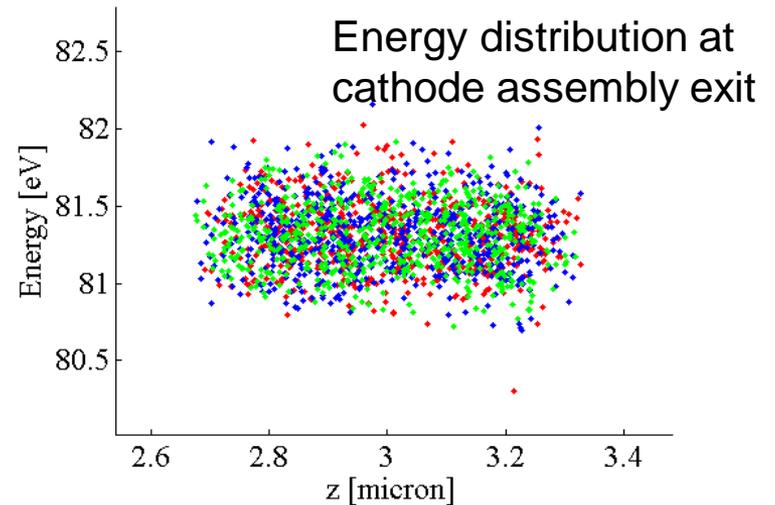
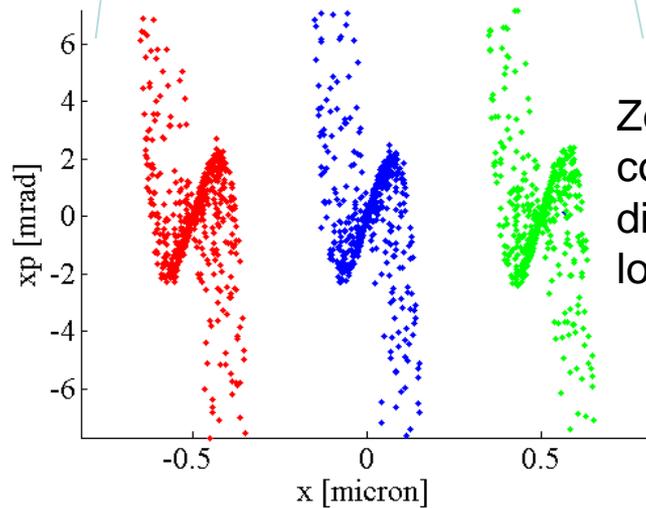
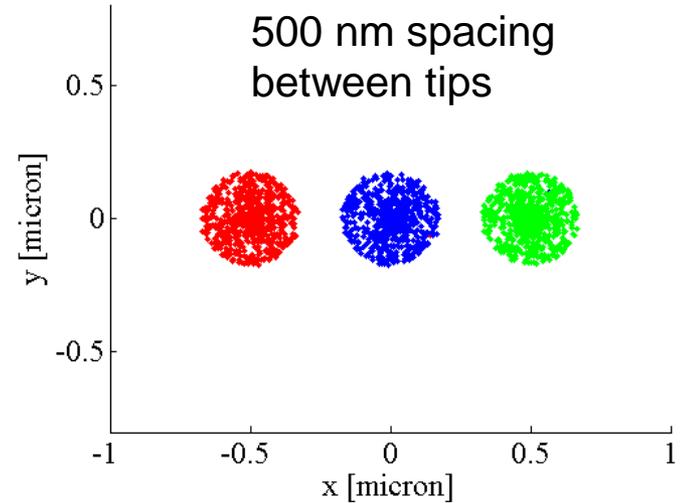
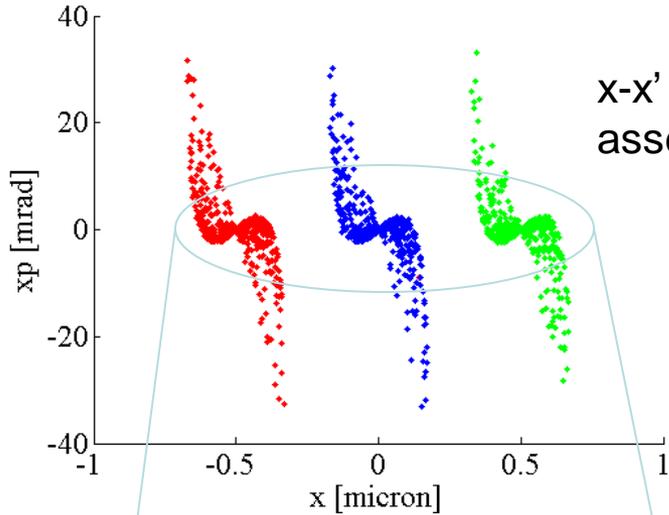
Design x-emittance = $1.93\text{e-}13$ m-rad
At cathode x-emittance = $1.91\text{e-}13$ m-rad

Build input distribution for PARMELA



Beam Dynamics of 3X1 Tip Array

PARMELA tracking results. No space charge



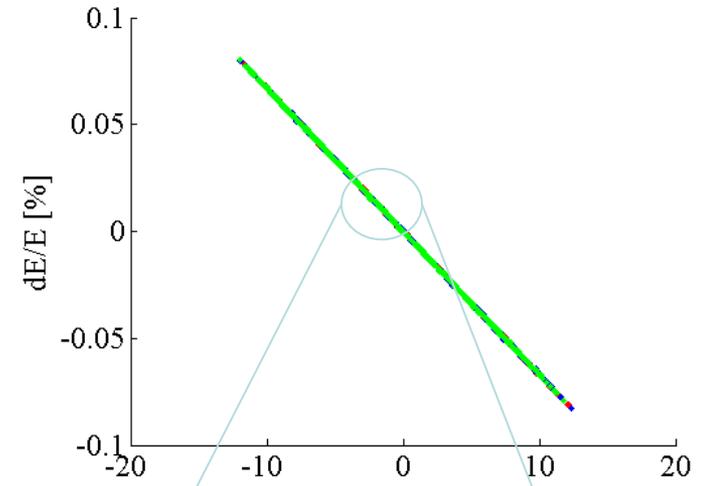
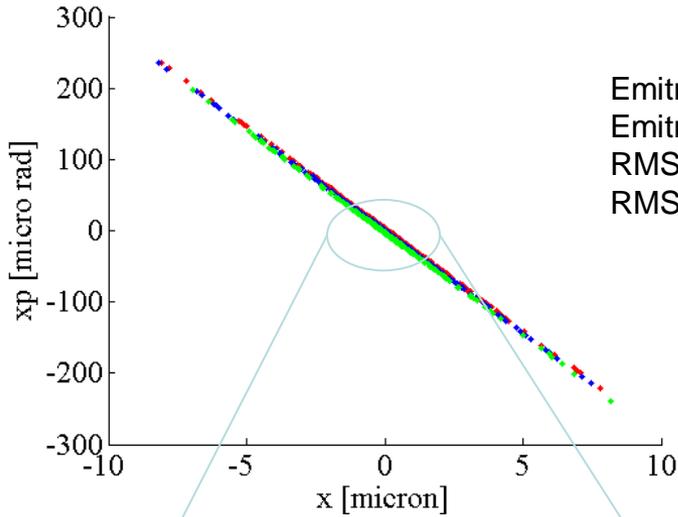
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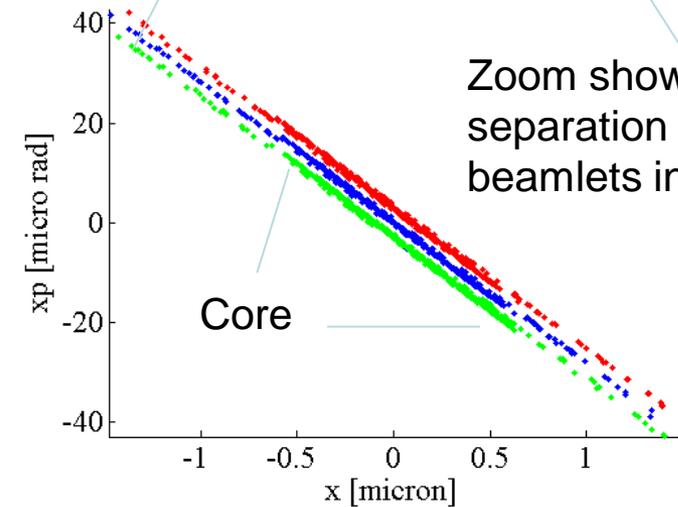
Transverse & Longitudinal Matching to EEX

PARMELA tracking results. No space charge

Emitnx = 4.4×10^{-11} m-rad
 Emitny = 7.8×10^{-12} m-rad
 RMS x size = 1467 nm
 RMS x divergence = 42 urad

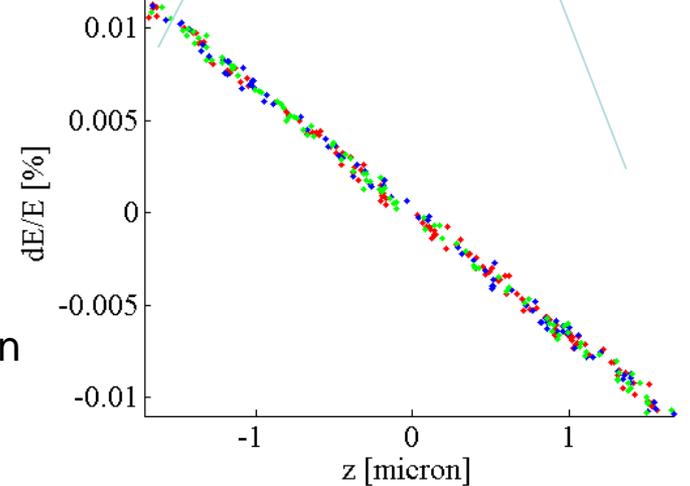


$E = 1.8$ MeV



Zoom shows separation of beamlets in $x-x'$.

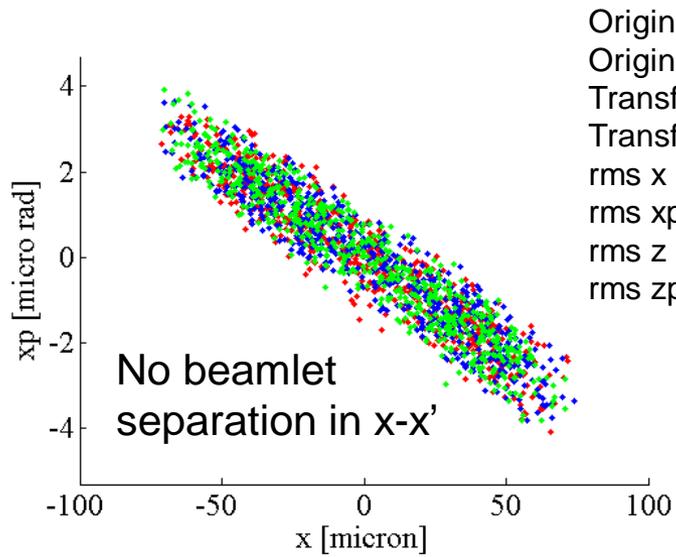
No beamlet separation in $z-z'$.



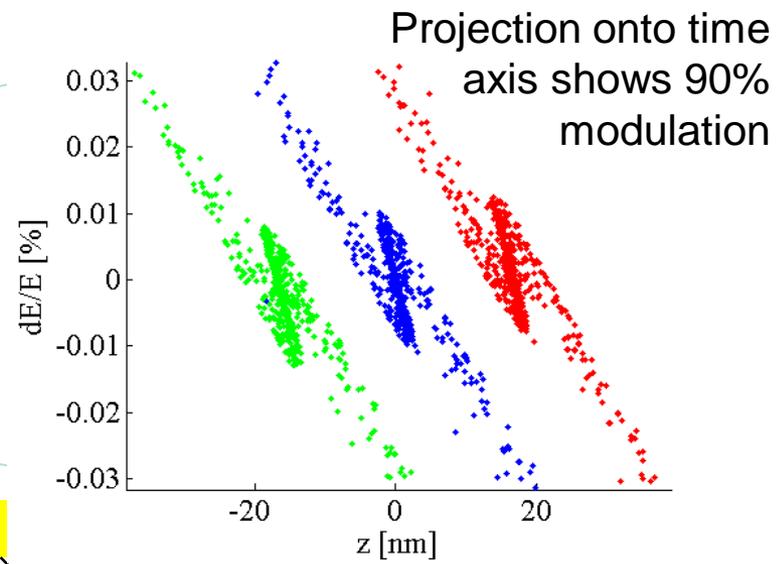
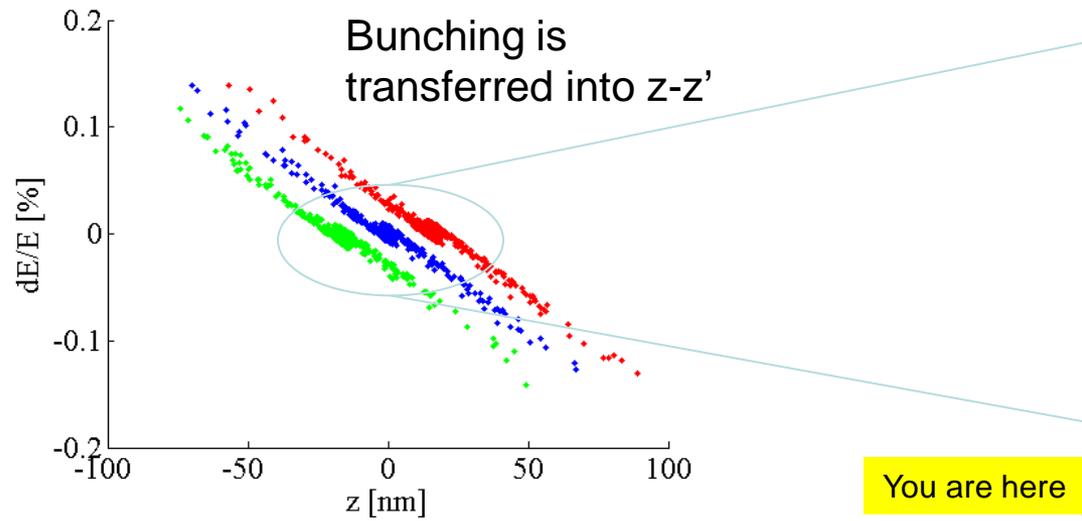
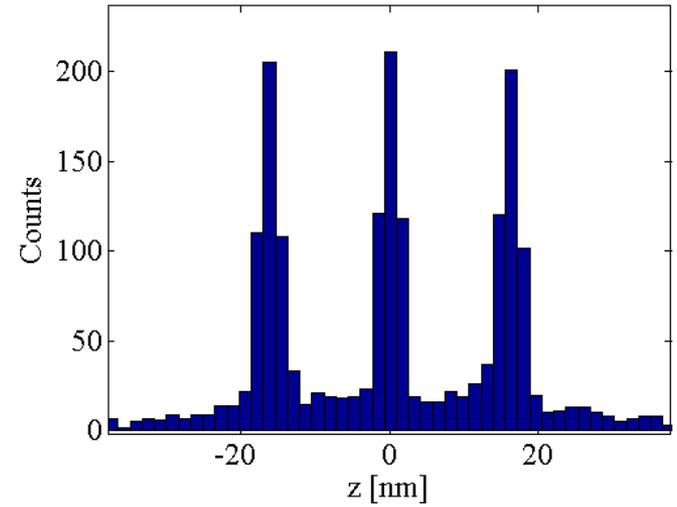
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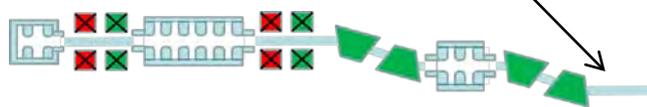
Bunched Beam after Emittance Exchange



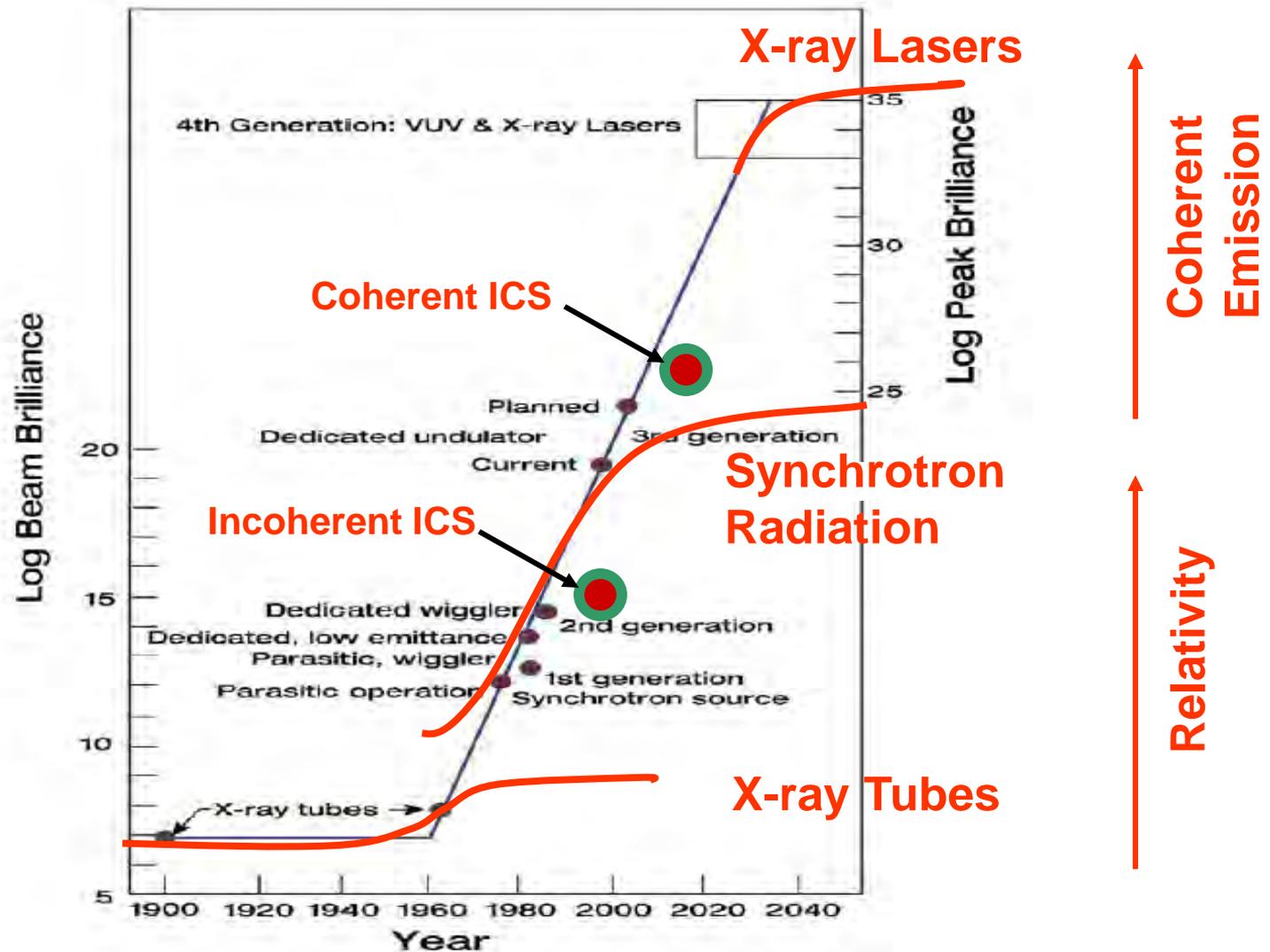
Original emitnx = 4.4×10^{-11}
 Original emitnz = 2.2×10^{-10}
 Transformed emitnx = 2.2×10^{-10}
 Transformed emitnz = 4.4×10^{-11}
 rms x = 35 micron
 rms xp = 1.67 micro rad
 rms z = 19.2 nm
 rms zp = 2.49×10^{-4} dE/E



You are here



Light Source Performance



Summary

Wide variety of light source activities at MIT

- Optical *femtosecond synchronization*
- High power *ultrafast lasers* for seeding, ICS, as HHG sources
- FEL *facility concepts* including high rep rate, many beamlines, CW stability, FEL dynamics studies
- ICS optimization, *prototyping*, and facility concepts
- 4K SRF *gun and linac development* with Jlab and others
- *Nanocathode* development for high brightness electron beams
- New concepts for *coherent x-ray emission*